

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Shigeru Terashima

Application No.: 10/785,252

Filed: February 23, 2004

For: EXPOSURE APPARATUS AND
EXPOSURE METHOD

Confirmation 8857
No.:

Examiner: Rutledge, Della J.

Art Unit: 2851

Mail Stop Amendments
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION/AMENDMENT

Madam:

In response to the Office Action mailed March 16, 2006, reconsideration of this action and allowance of the claims of the present application are respectfully requested in view of the following remarks:

Remarks/Arguments begin on page 2 of this paper.